



Docket No. 740756-2183

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
Shunpei YAMAZAKI)	Group Art Unit: Nathan Ha
Serial No. 09/620,968)	Examiner: 2814
Filed: July 20, 2000)	Confirmation No. 4214
For: METHOD OF FORMING INSULATING FILMS, CAPACITANCES, AND SEMICONDUCTOR DEVICES)	Dated: July 26, 2006

RESPONSE

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 28, 2006, please amend the above-identified application as follows:

Remarks begin on page 6.